

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ricky Amos, et al. **Examiner:** Matthew C. Landau
Serial No: 09/995,031 **Art Unit:** 2815
Filed: November 29, 2001 **Docket:** YOR920010633US1 (19031)

For: HIGH TEMPERATURE PROCESSING COMPATIBLE METAL GATE ELECTRODE
FOR pFETs AND METHOD FOR FABRICATION

Confirmation No: 9669
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dated: June 23, 2008

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Rejection dated April 24, 2008, Applicants respectfully request that the following amendments and remarks be entered as of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on June 23, 2008.

Dated: June 23, 2008


Harry Andrew Hild Jr.